

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 2863  
Examiner : Xiuqin Sun  
Applicants : Kenichiro Kobayashi et al.  
Appln. No. : 10/737,336  
Filing Date : December 16, 2003  
Confirmation No. : 6152  
For : METHOD AND APPARATUS FOR DIRECT IMAGE PICK-UP OF  
GRANULAR SPECK PATTERN GENERATED BY REFLECTING  
LIGHT OF LASER BEAM

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

AMENDMENT UNDER §1.312

Please amend the above-identified application as follows.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.